



Amendment Under 37 C.F.R. § 1.116
Group Art Unit 2881, Expedited Procedure

00862.022032.

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

HIROSHI TSUJI ET AL.

Application No.: 09/691,234

Filed: October 19, 2000

For: ELECTRON BEAM LITHOGRAPHY)
APPARATUS :

Examiner: J. Berman

Group Art Unit: 2881

October 6, 2003

Mail Stop AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

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AMENDMENT AFTER FINAL REJECTION AND
PETITION FOR EXTENSION OF TIME

Sir:

Applicants petition to extend the time for response to the Office Action of
June 4, 2003, to and including Saturday, October 4, 2003. A check in the amount of
\$110.00 in payment of the extension fee is enclosed. Please charge any additional fee and
credit any overpayment to our Deposit Account 06-1205.

10/10/2003 SSITHIB1 00000012 09691234

02 FC:1201 1032.00 OP
03 FC:1202 324.00 OP

10/10/2003 SSITHIB1 00000012 09691234

01 FC:1251 110.00 OP

I hereby certify that this correspondence is being deposited with the
United States Postal Service as first-class mail in an envelope
addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria,
VA 22313-1450 on October 6, 2003.

(Date of Deposit)

FRANK A. DeLUCIA, JR. (REG. #42,476)

(Name of Attorney for Applicant)

Signature

October 6, 2003

Date of Signature

In response to that Office Action, please amend the above-identified application as follows.

The claims are listed beginning at page 3. The Remarks begin at page 19.